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CONFIRMATION NO. 3218

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**** CONTINUING DATA *******
 This application is a CON of 09/291,538 04/14/1999 ABN
 which is a DIV of 08/911,505 08/14/1997 PAT 6,274,414

**** FOREIGN APPLICATIONS *******
 JAPAN HEI8217424 08/19/1996

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
**** 02/23/2004**

Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 25	TOTAL CLAIMS 5	INDEPENDENT CLAIMS 1	
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance					
Verified and Acknowledged	Examiner's Signature	Initials			

ADDRESS
000026021

TITLE
LASER ANNEAL METHOD OF A SEMICONDUCTOR LAYER

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